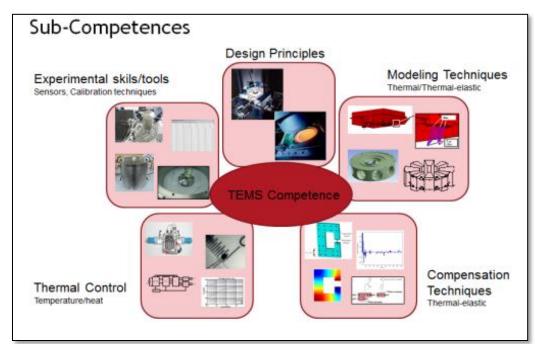
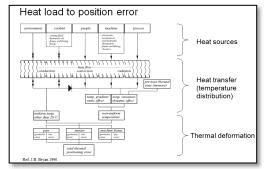
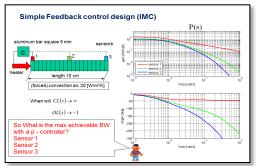
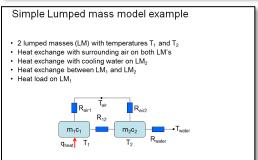
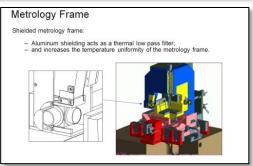
Thermal Effects in Mechatronic Systems

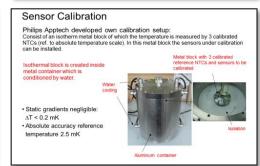














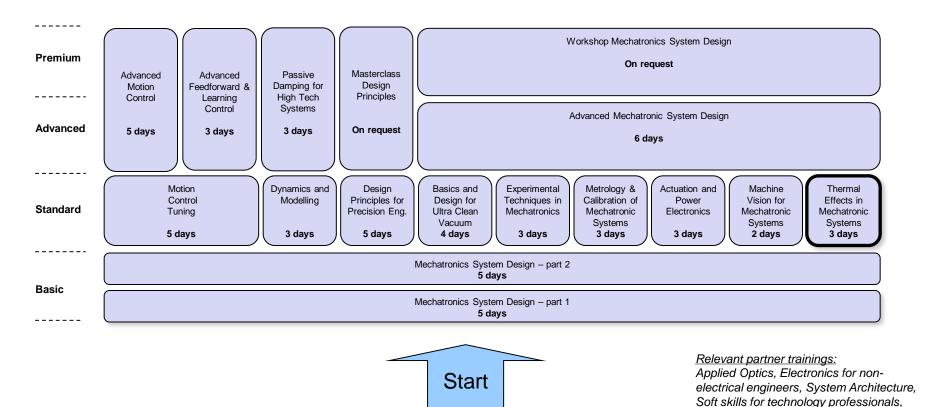
Contents

- Mechatronics Training Curriculum
- Details of Course Thermal Effects in Mechatronic Systems





Mechatronics Training Curriculum



www.mechatronics-academy.nl





Mechatronics Academy

- In the past, many trainings were developed within Philips to train own staff, but the training center CTT stopped.
- Mechatronics Academy B.V. has been setup to provide continuity of the existing trainings and develop new trainings in the field of precision mechatronics. It is founded and run by:
 - Prof. Maarten Steinbuch
 - Prof. Jan van Eijk
 - Dr. Adrian Rankers
- We cooperate in the High Tech Institute consortium that provides sales, marketing and back office functions.





Thermal Effects in Mechatronic Systems





Course Director(s) / Trainers

Teachers

- Dr.ir. T.A.M. Ruijl (MI-Partners)
- Ing. J. van der Sanden (ASML)
- Ir. Marco Koevoets (ASML)
- Dr.ir. Rob van Gils (Philips Innovation Services)

Course Director(s)

- Dr.ir. T.A.M. Ruijl (MI-Partners)
- Dr.ir. A.M. Rankers (Mechatronics Academy)





Program

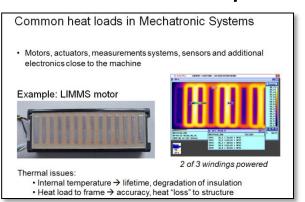
Day	Contents
1	Basic Theory
	Lunch
	Basic Theory - continued
	Introduction to modeling techniques: building lump-mass models part
2	Recap day
	Precise temperature measurements
	Case Cryo
	Lunch
	Case, Cryo - continued
	Design for Thermal Stability + Case Shielding
3	Active Thermal Control
	Lunch
	Advanced Topics - model reduction / thermal modes / compensation & sensor placement

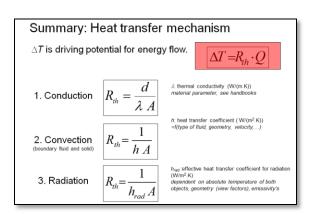


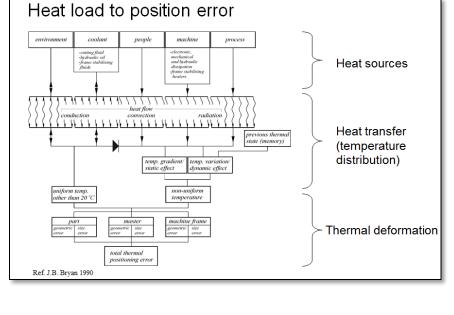


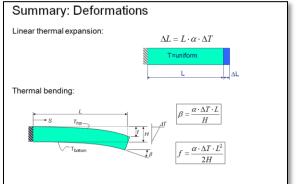
Day 1 (morning): Basic Theory

- Heat loads
- Theory of heat transfer
- Theory fluid flow
- Theory thermal deformations
- Transient effects
- Vacuum aspects











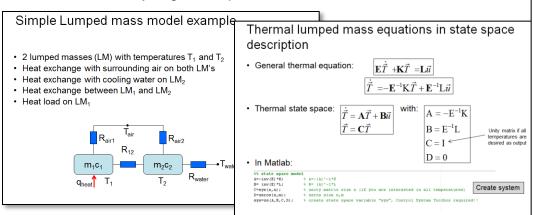


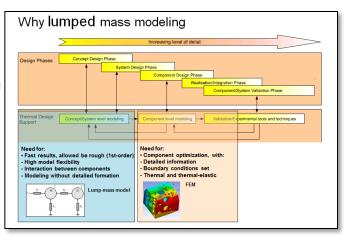
Day 1 (afternoon): Modelling

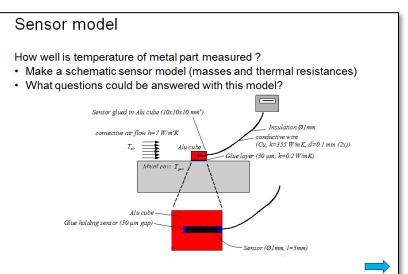
- Why lumped mass modeling
- Simple Lumped mass model example
- Analysis and simulation using a state space description
 - Stationary solution
 - Transient simulation
 - Frequency domain analysis

Exercises

- simple lumped mass model (deriving system matrices)
- effects of cooling water
- analyzing a temperature sensor









Day 2 (morning): Temp. Measurement

Spot Sensor types:

- Thermocouples
- Resistance based sensors
 - RTD (Resistance Temperature Detector)
 - Thermistor: NTC (Negative Temperature Coefficient)

Performing Real Measurements

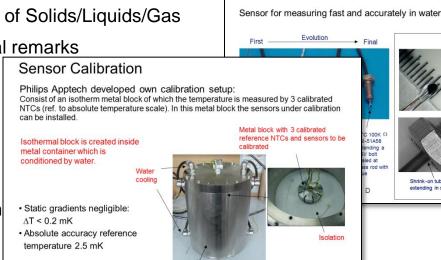
- From True to Observed value
- Real Ideal Sensor Model
- Temperature measurement of Solids/Liquids/Gas

Dynamic behaviour, general remarks

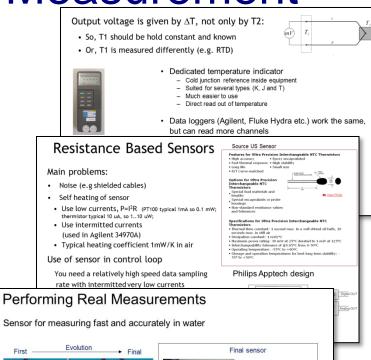
Sensor Calibration

IR Temperature Meters:

- Principle and limitations
- IR spot meters
- IR scanners/imaging system



Aluminum container



extending in side bolt





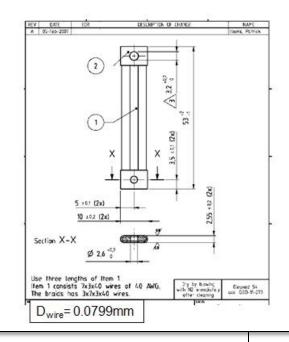
Day 2 (morning/afternoon): Case

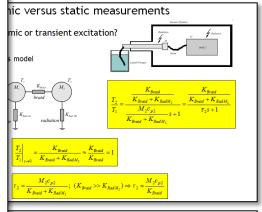
Exercise: Determine thermal resistance of braid

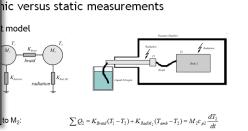
This braid is used in an electron microscope to cool a sample, which is positioned on a TEM stage, down to cryogenic temperatures (e.g. 100 K).

Braid between cooling rods









Laplace s:

Transferfunction:

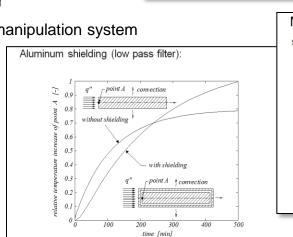
$$\begin{split} K_{Braid}T_{1} - (K_{Braid} + K_{EadM_{1}})T_{2} &= M_{1}c_{p2}sT_{2} \\ \frac{T_{2}}{T_{1}} &= \frac{K_{Braid}}{K_{Braid} + K_{EadM_{1}}} + \frac{K_{Braid}}{M_{1}c_{p2}} + 1 \\ \frac{T_{2}}{K_{Braid} + K_{EadM_{1}}} + T_{2} &= \frac{K_{Braid}}{T_{2}s + 1} \end{split}$$



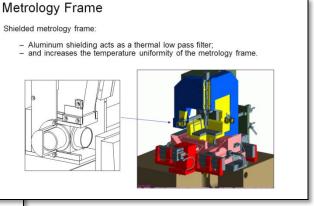


Day 2 (afternoon): Design for TEMS

- Basic design rules for precision equipment
- Structural and metrology function
- Thermal design considerations
- Example case: Ultra precision CMM
 - System level design approach
 - Structural and metrology function
 - Thermal shielding
 - Metrology frame support
 - Static versus transient behavior
 - Minimizing heat generation in manipulation system
 - Thermal compensation
 - Shielding and enclosure (case)



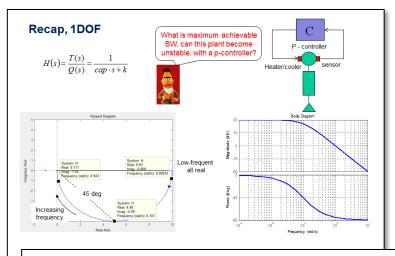
Common CMM with micron accuracy Simple down scaling? New machine concept? Concept analysis on Metrology/Dynamics/Thermal showed that downscaling only is not enough, different machine concept is needed.

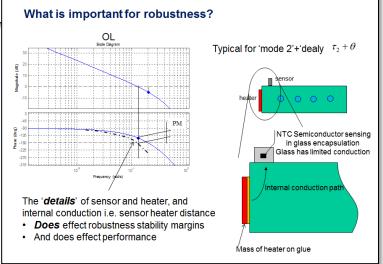


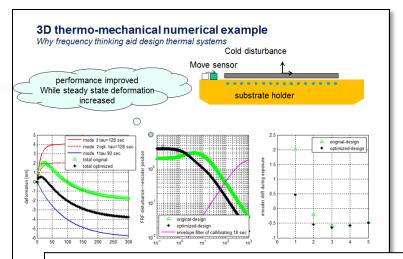


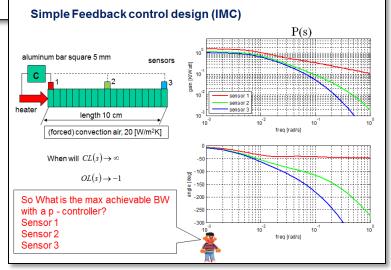


Day 3 (morning): Active Thermal Control





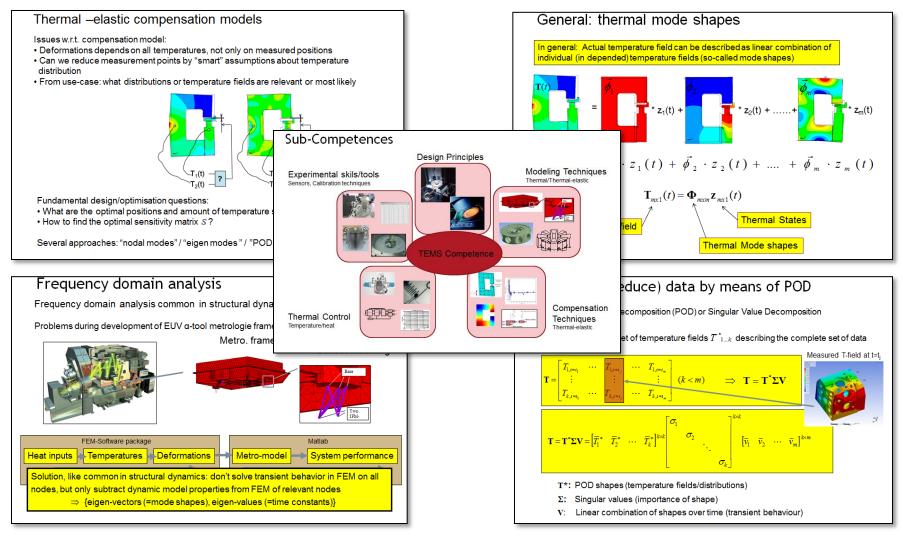








Day 3 (afternoon): Advanced Topics







Sign-up for this training

Via the website of our partner
High Tech Institute



